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Bib Data Sheet

CONFIRMATION NO. 7739

SERIAL NUMBER 10/601,561	FILING DATE 06/24/2003 RULE	CLASS 118	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. SEC.828D
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APPLICANTS

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**** CONTINUING DATA *******
 This application is a DIV of 09/884,993 06/21/2001 PAT 6,623,798 ✓ *ku 11/5/04*

**** FOREIGN APPLICATIONS *******
 REPUBLIC OF KOREA 2000-34485 06/22/2000 ✓ *ku 11/5/04*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
**** 08/18/2003**

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 3	TOTAL CLAIMS 6	INDEPENDENT CLAIMS 1
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TITLE
 Chemical vapor deposition method for depositing silicide and apparatus for performing the same